

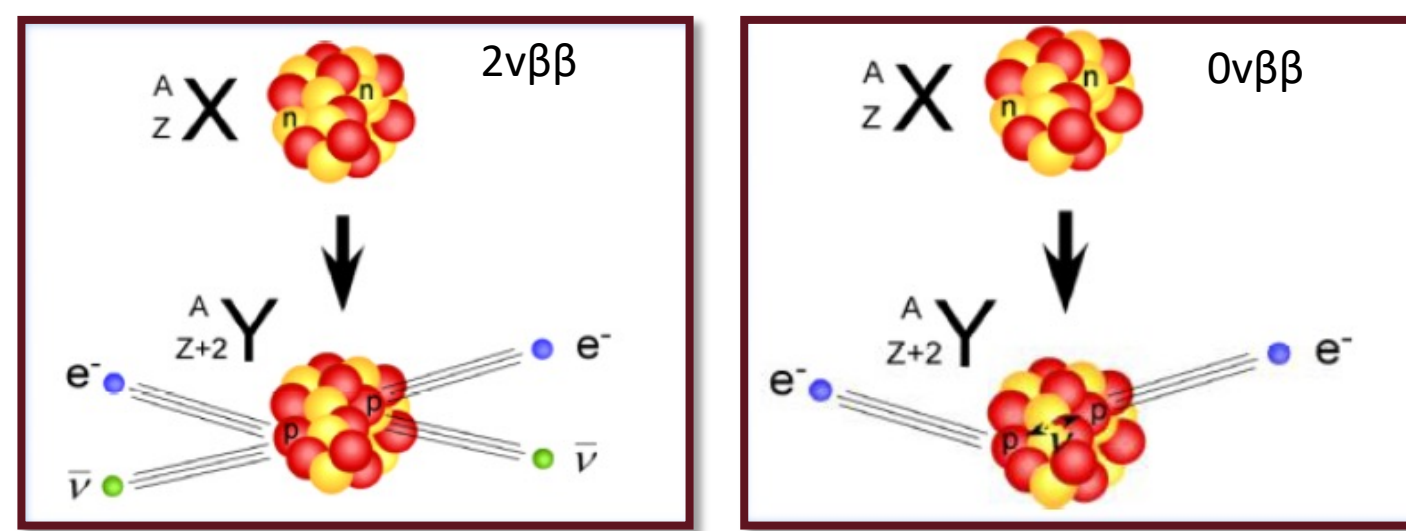
Development of Laser Isotope Separation (LIS) of ^{48}Ca for the search of neutrinoless double beta decay by CANDLES

Anawat Rittirong*, LIS and CANDLES collaborations

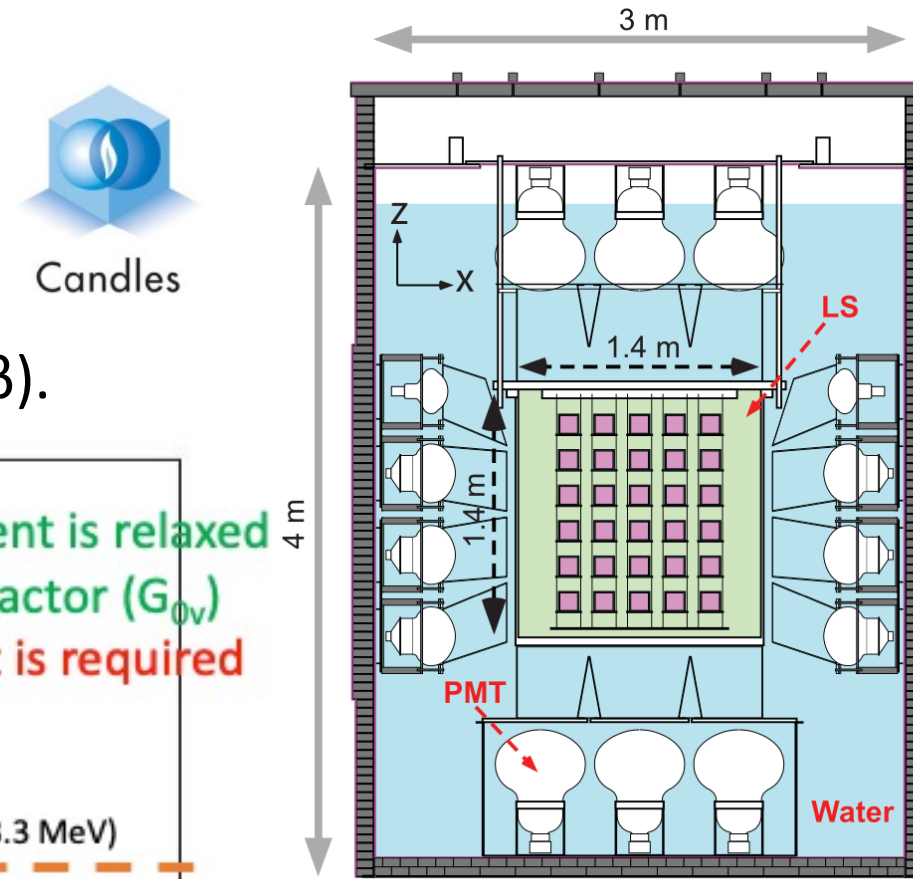
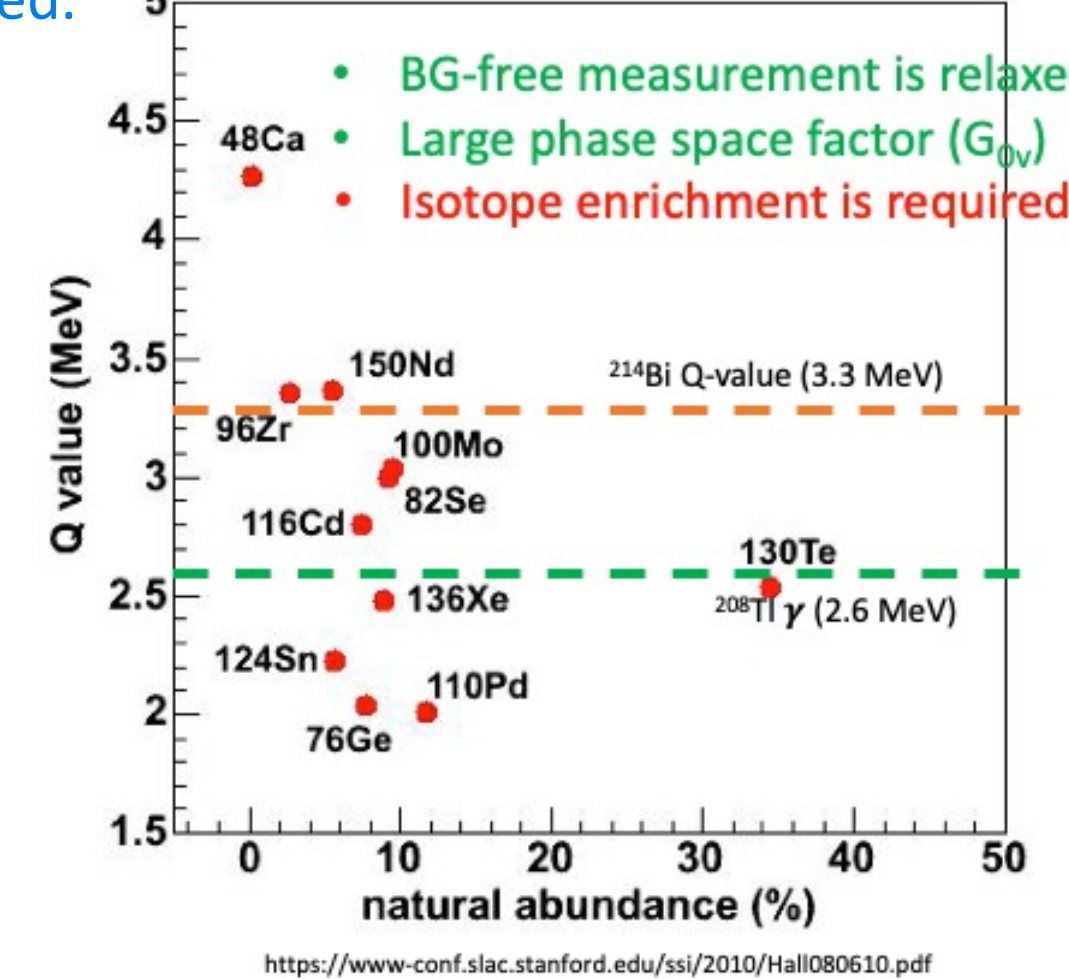
UGRP2024, Osaka University, July 05th – 06th, 2024

CANDLES

- Purpose:** To verify the Majorana nature of neutrino via neutrinoless double beta decay ($0\nu\beta\beta$).
- ^{48}Ca (Q-value = 4.27 MeV, highest energy for $2\beta\beta$ decay) is used.

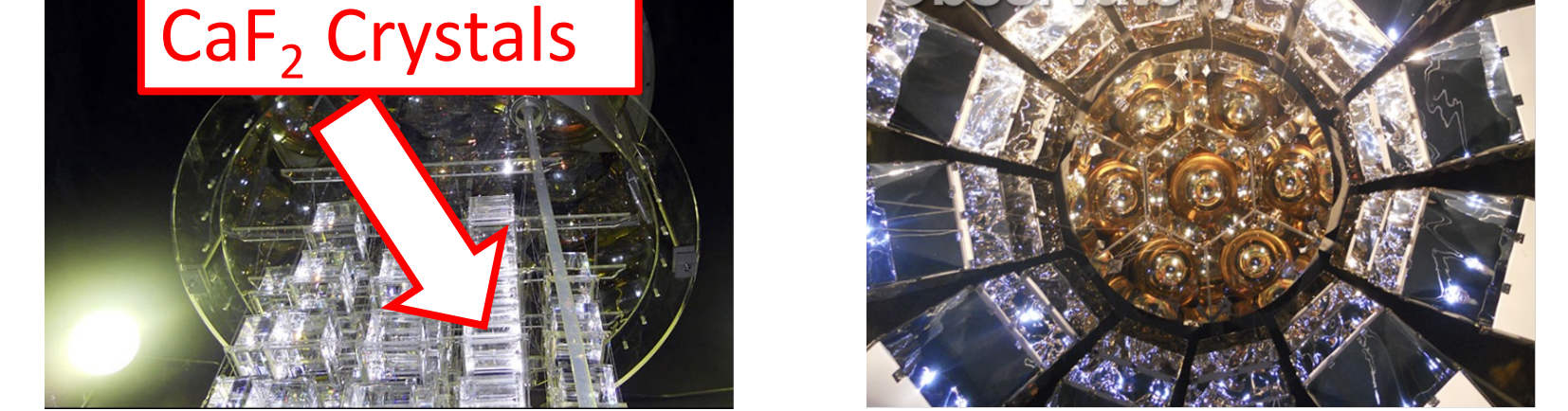


$0\nu\beta\beta$ is beyond the standard model!!



S. Ajimura, et al. *Physical Review D* 103.9 (2021): 092008.

CANDLES III – 305 kg CaF_2 Crystals (3.2 kg $\times$ 96 pieces) **0.35 kg ^{48}Ca**
10⁻³ events/keV/yr/(kg of ^{48}Ca) at 4.26 MeV

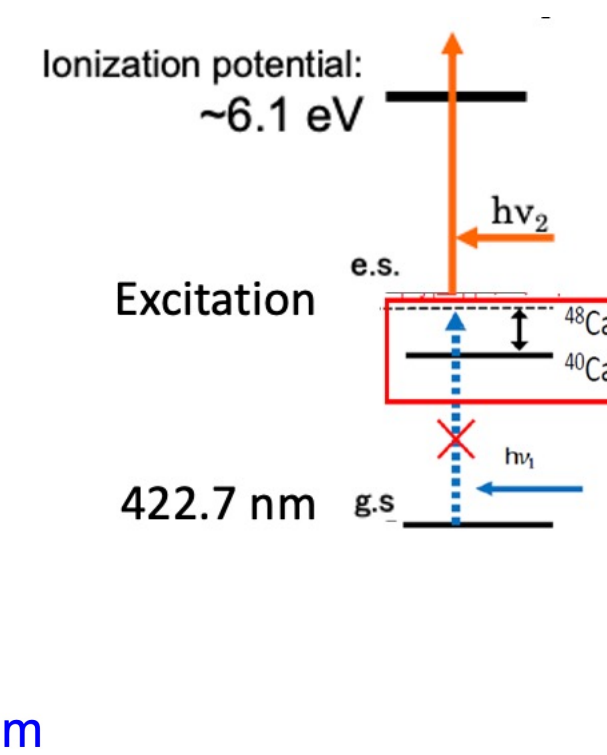
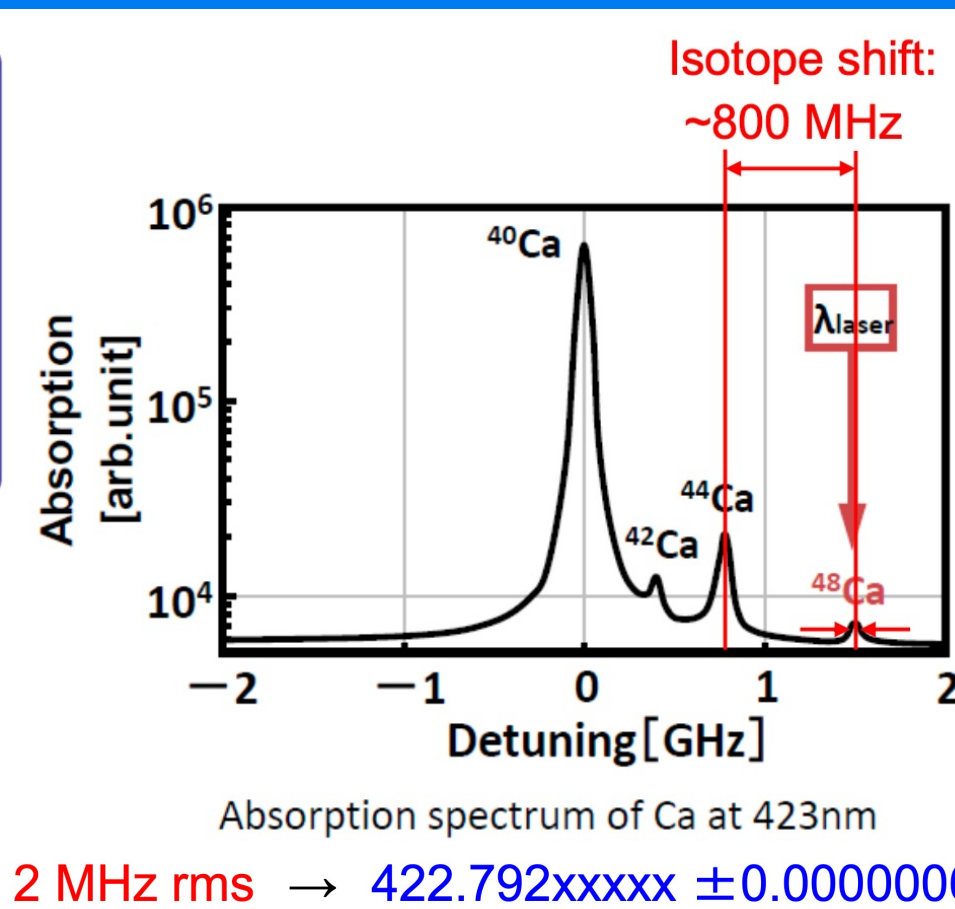
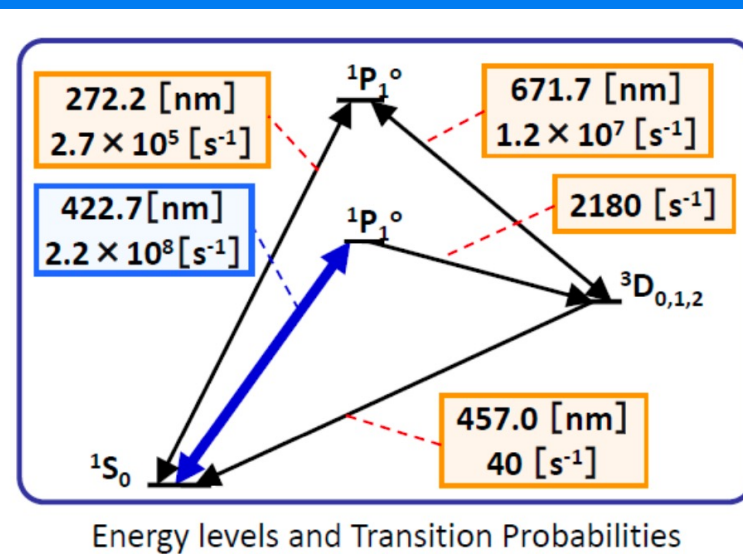


Large amount of ^{48}Ca is required (tons scale)

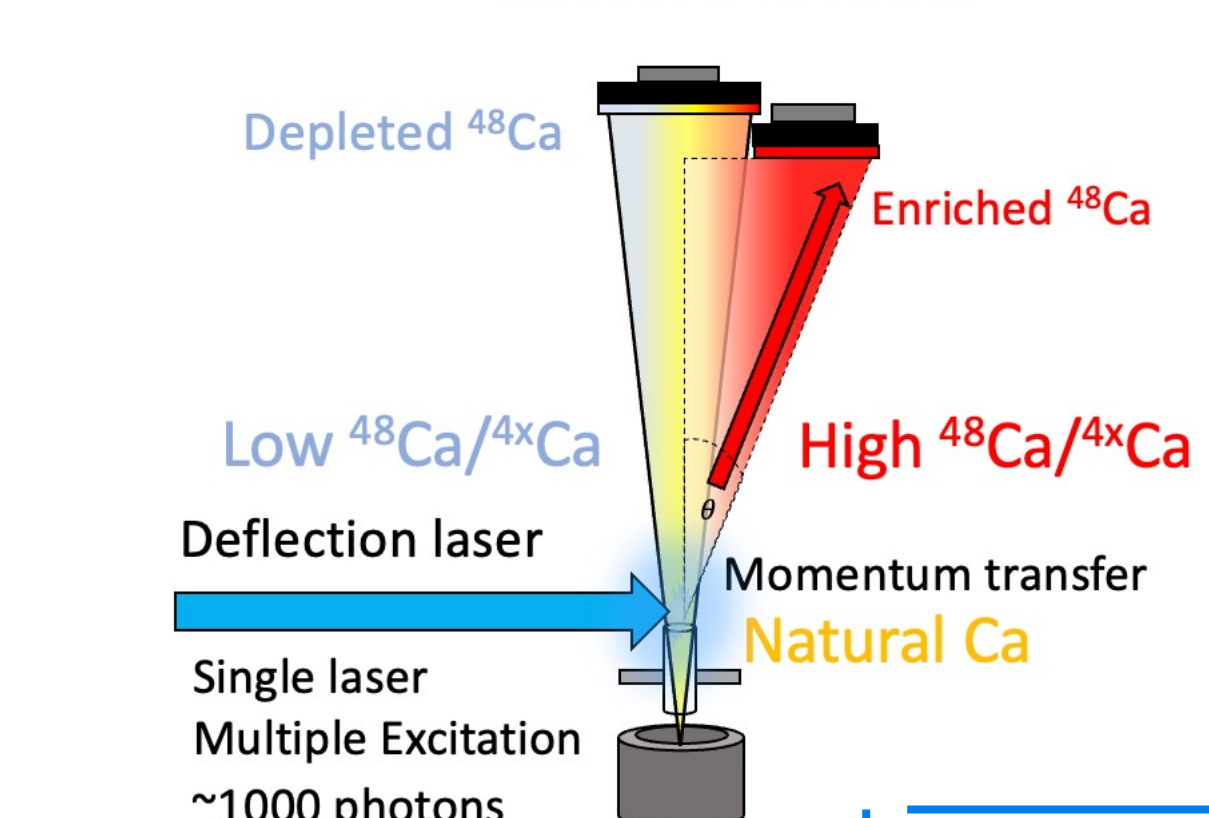
- Regrettably, the gas centrifuge or gas diffusion techniques are not viable for the isolation of calcium due to the unavailability of the gaseous compound.
- Expensive [$\sim 1,000,000$ \$/g] via an electromagnetic separator**

Requirement: $\sim 0.36 - 13$ kmol of ^{48}Ca
 $\sim 1800 \times$ CANDLES III

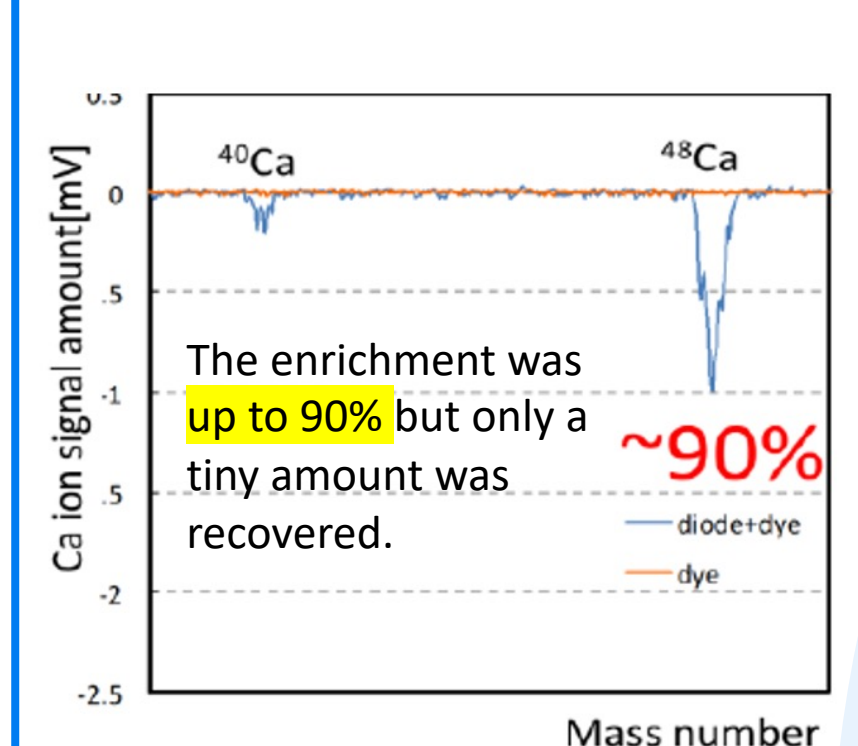
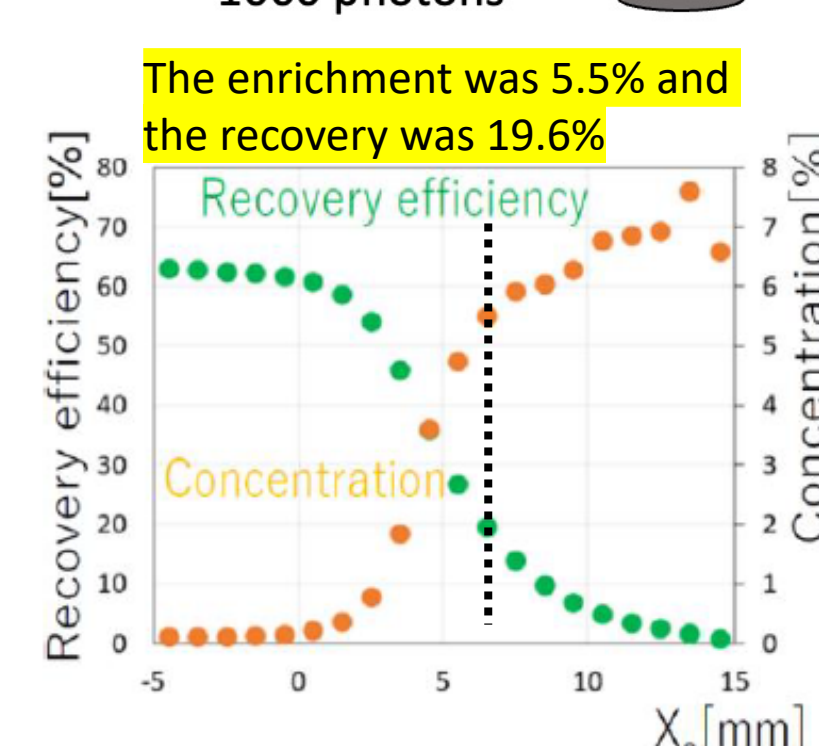
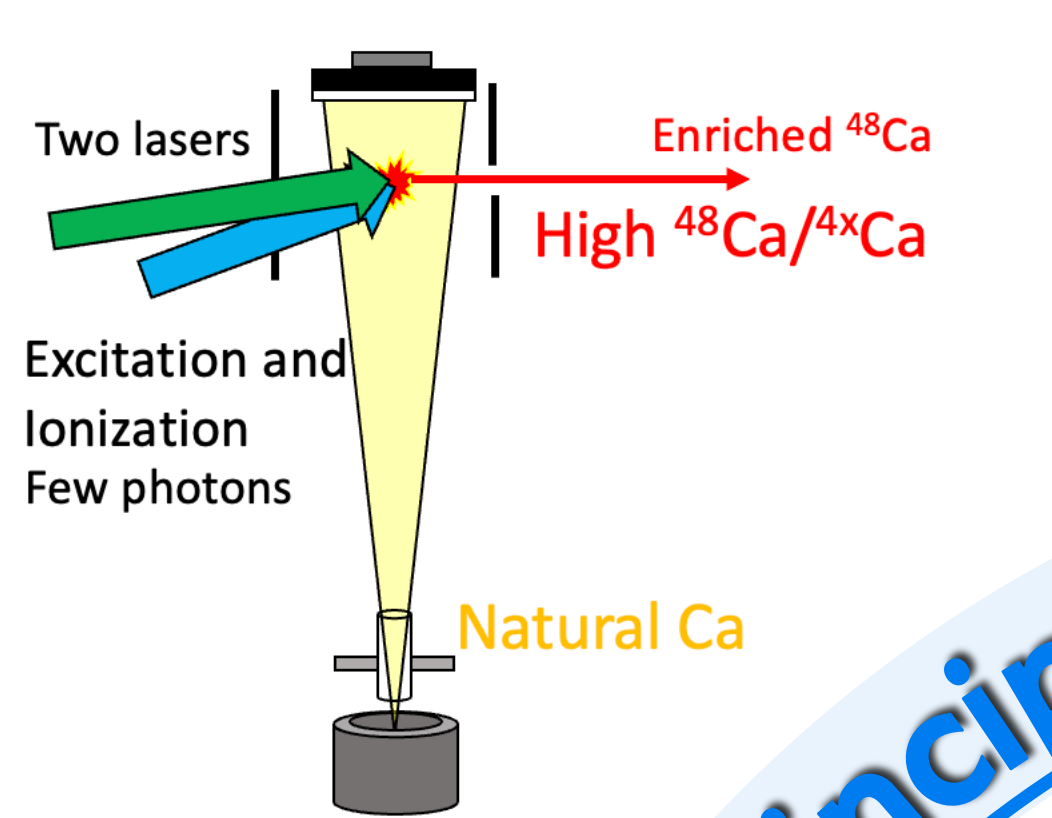
Ca Isotope	^{40}Ca	^{42}Ca	^{43}Ca	^{44}Ca	^{46}Ca	^{48}Ca
% abundance	96.94	0.65	0.135	2.09	0.004	0.187



Deflection method



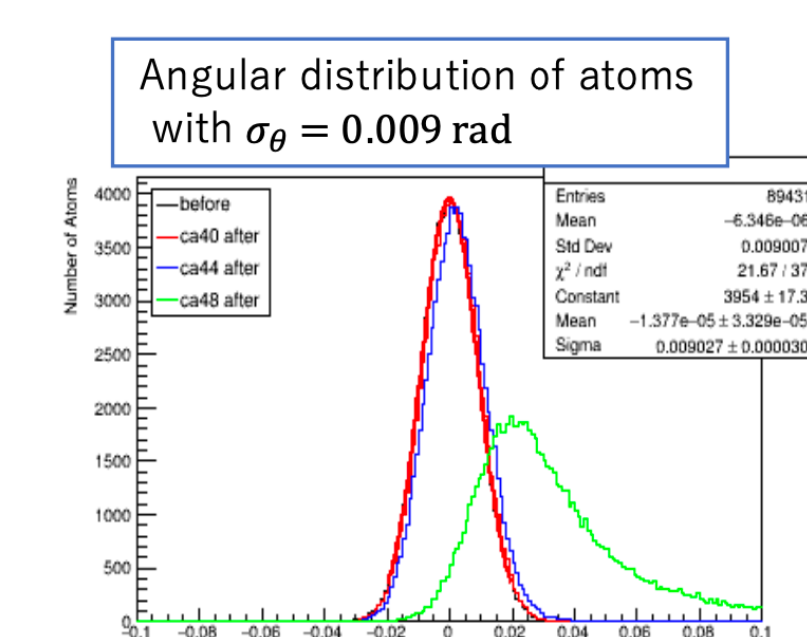
Ionization method



The DEFLECTION method is applicable for mass production.

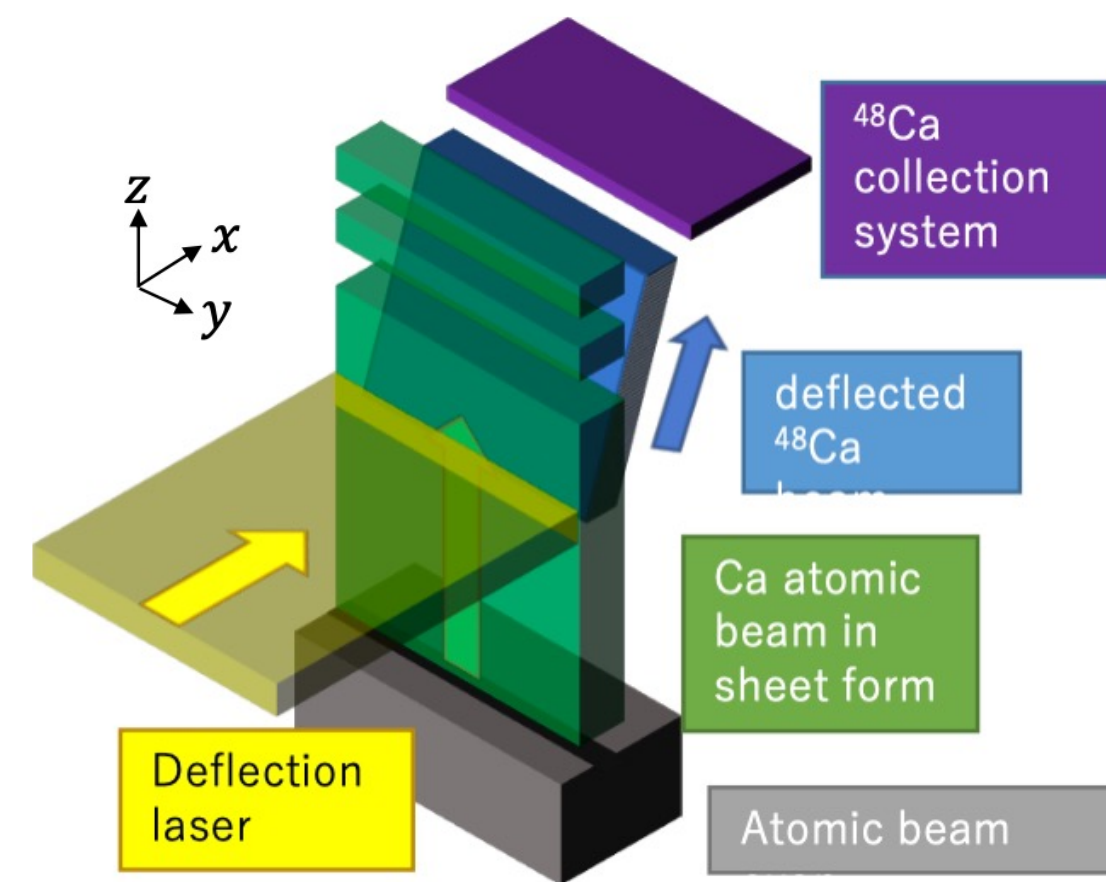
Requirements for an atomic beam system

- High intensity
 - Increase crucible temperature (600 °C)
- Well-collimated and highly efficient
 - Develop the collimator
- Maximum allowable spread angle



Setup simulation by GPS

- Gaussian beam at 873 K
- Laser power: 85 mW



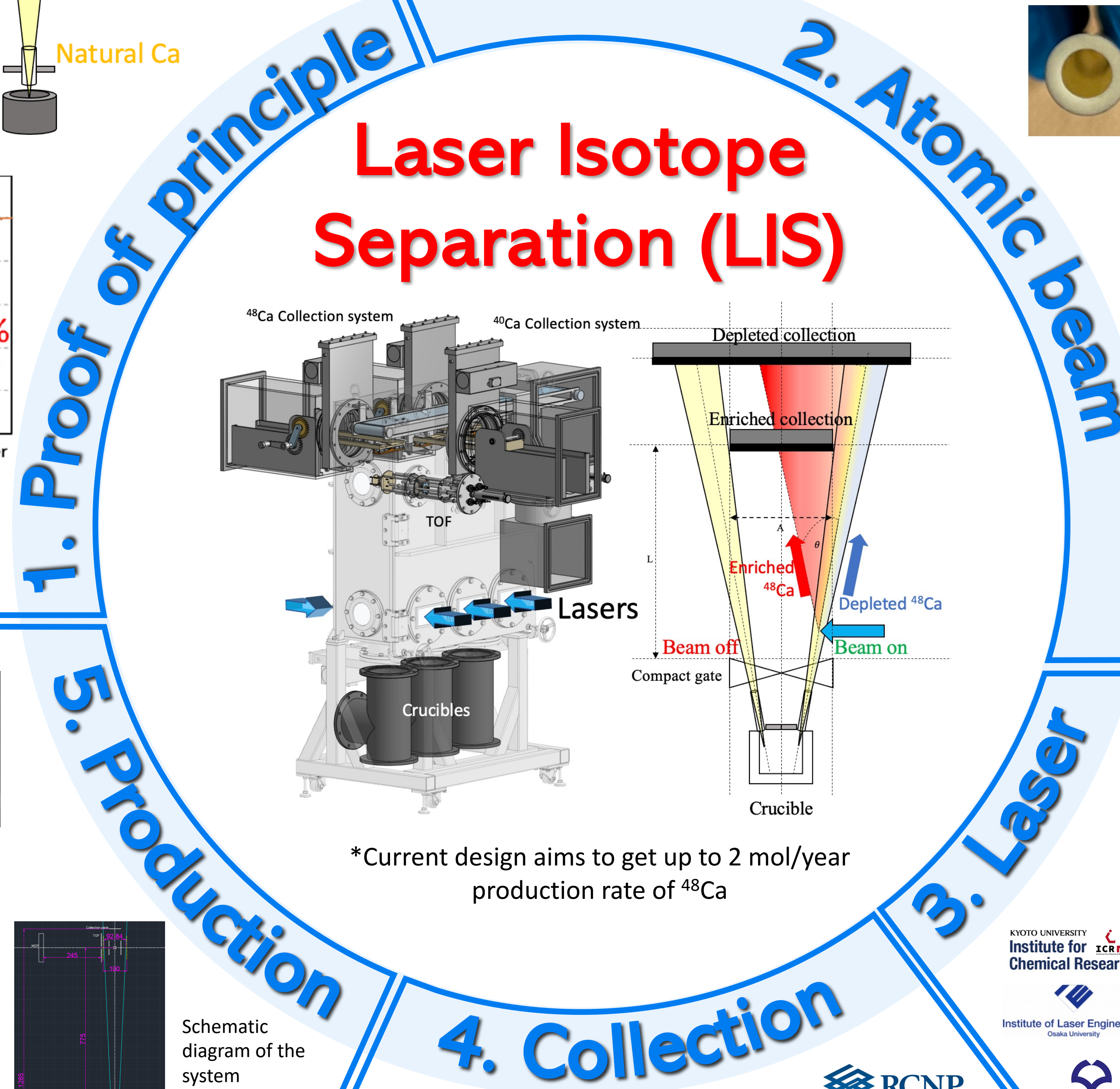
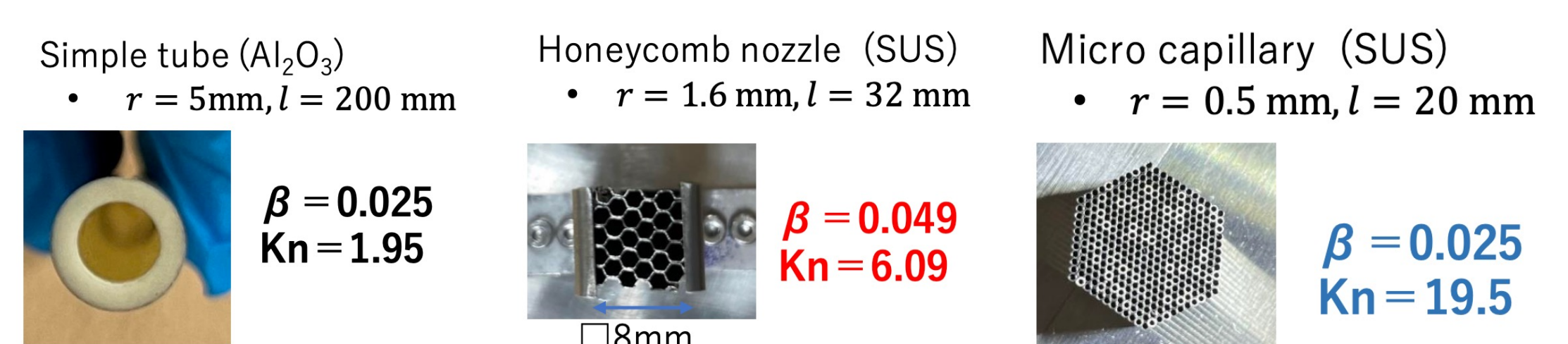
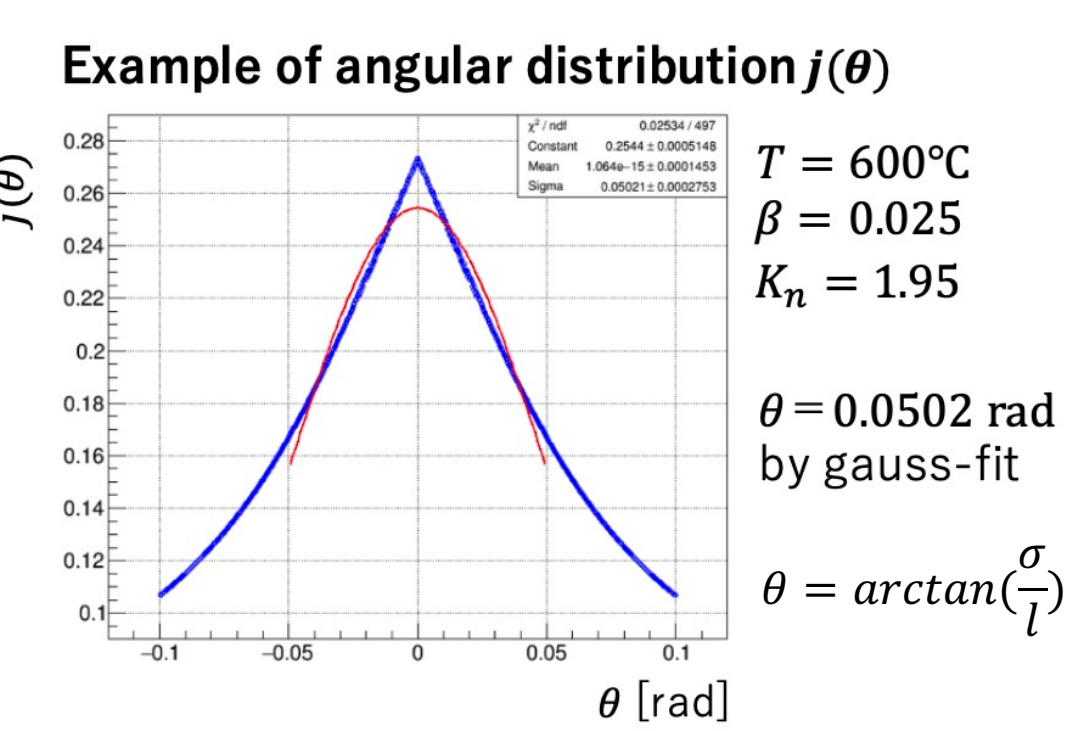
Aim for a sheet-like atomic bear

How to treat the atomic beam

Equations for the atomic beam parameters:

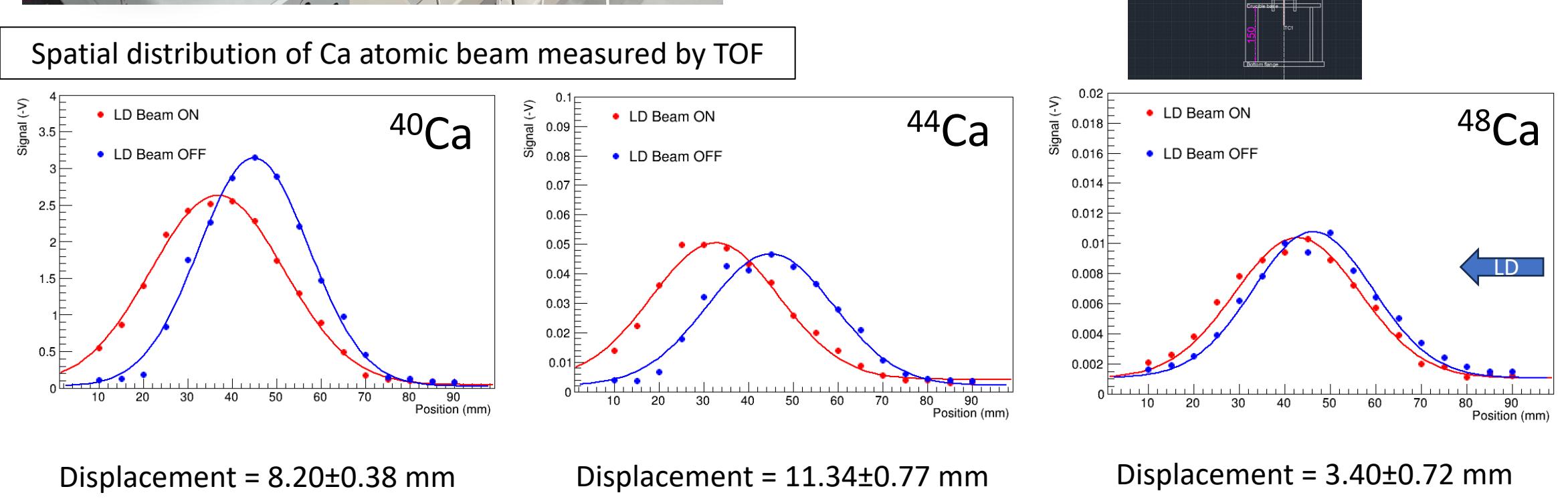
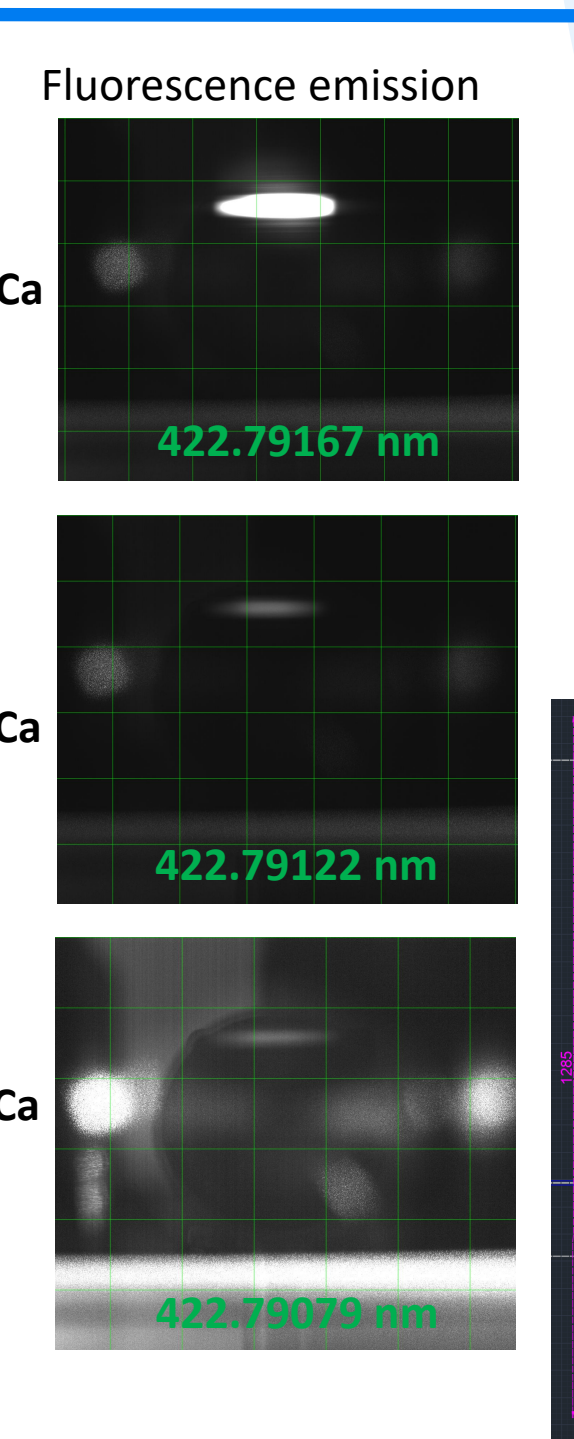
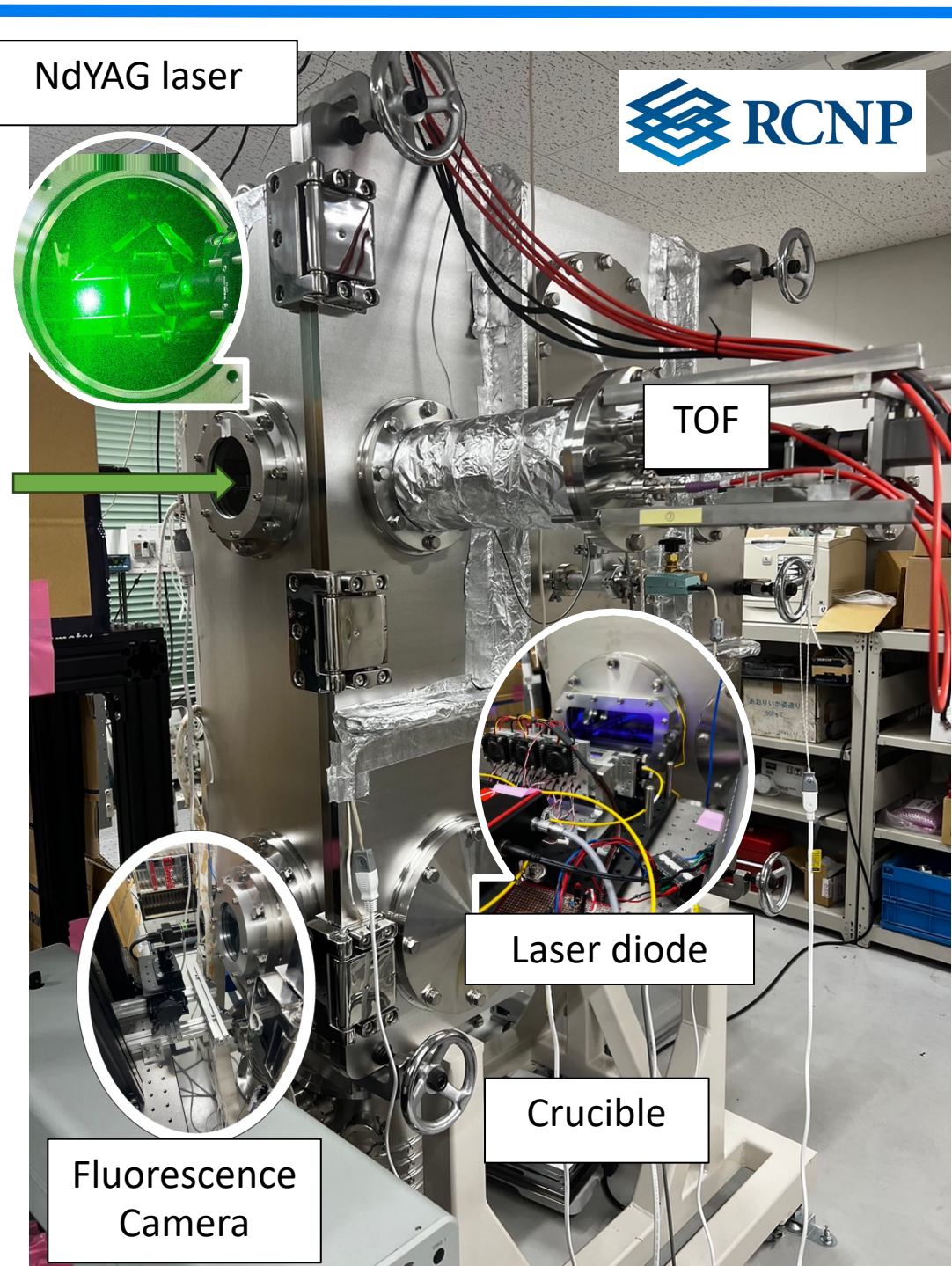
$$K_n = \frac{\lambda}{D}$$
$$\beta = \frac{2r}{L}$$

Where λ is the wavelength, D is the diameter, r is the radius, and L is the length.



Laser Isotope Separation (LIS)

*Current design aims to get up to 2 mol/year production rate of ^{48}Ca



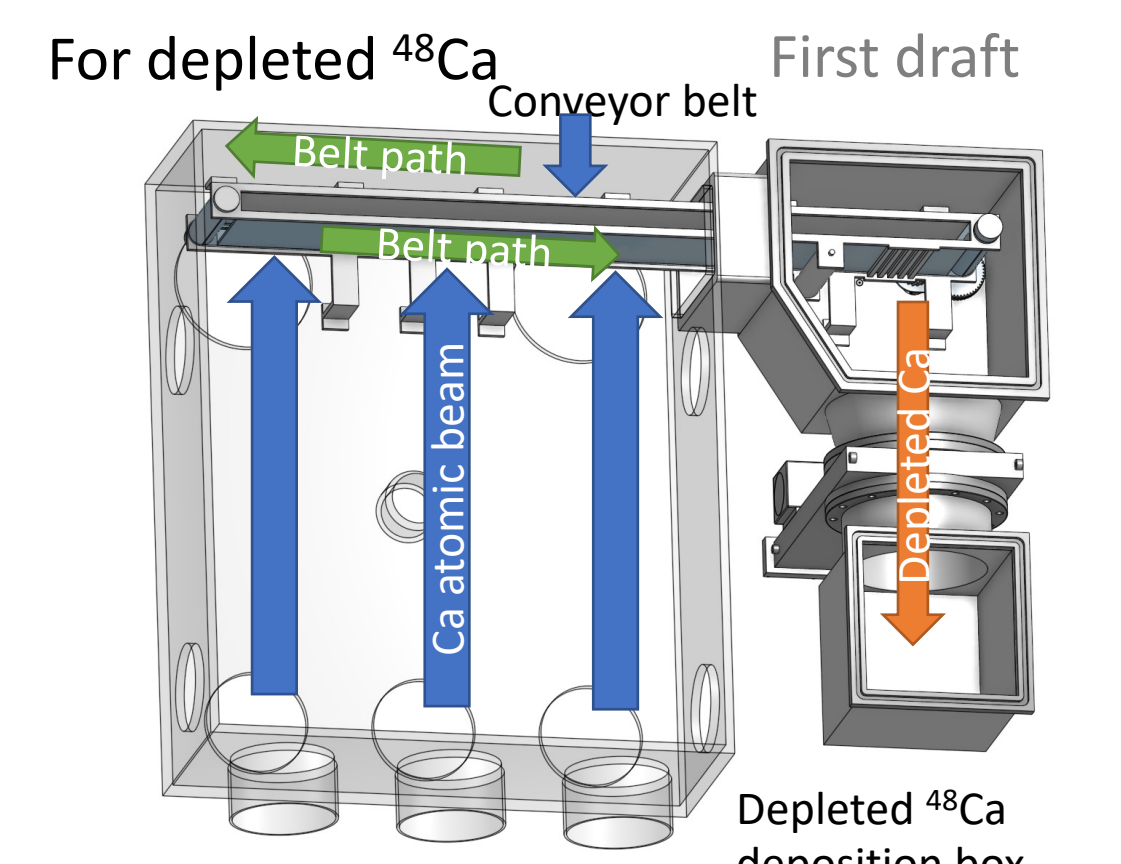
What is the required laser power?

Photon energy: 4.7×10^{-19} J @ 423 nm
Number of photons absorbed by 1 atom: 1,000
→ Number of ^{48}Ca produced by 1 W laser: $2 \times 10^{15} \text{ sec}^{-1}$ → **5 g/year**

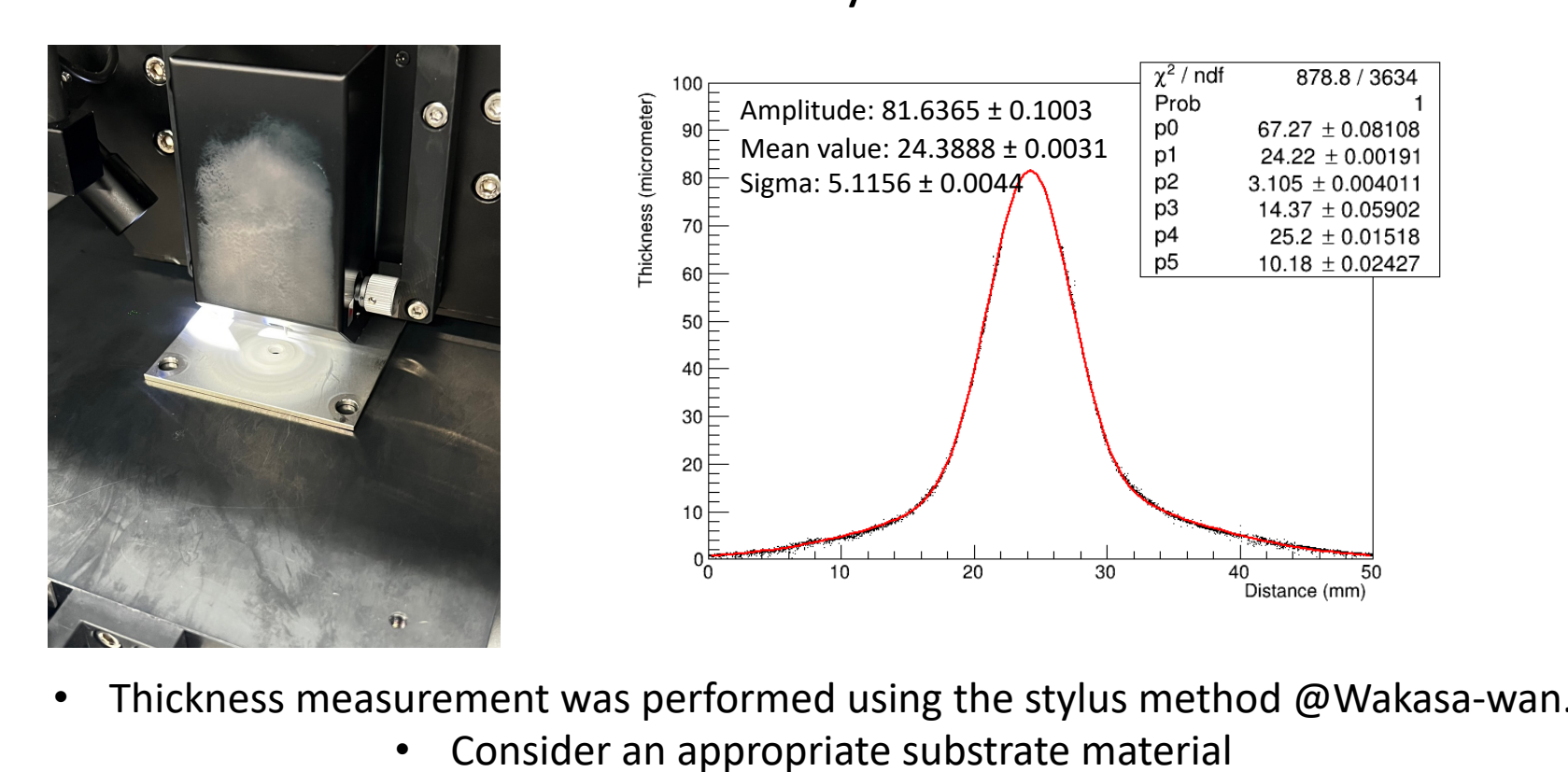
>200 W of laser power produces ^{48}Ca of 1 kg/year.

Current: 100 mW → 2 W → 2 kW → 60 kW
SOON: (~10 g/year) → (~10 kg/year) → (~300 kg/year)

- Automated production system ~ 42.8 kg of ^{48}Ca → 2 mol of ^{48}Ca



Determine the collection efficiency on substrate material



Thickness measurement was performed using the stylus method @Wakasa-wan.

Consider an appropriate substrate material

Calcium recovery by chemical method: production of $\text{Ca}(\text{OH})_2$

Tested on crucible lid

Consolidated substrate

Expose to air to form CaO

Soak with water in an ultrasonic cleaner to get $\text{Ca}(\text{OH})_2$

Settling and filtration of the powder and drying it in an oven heater

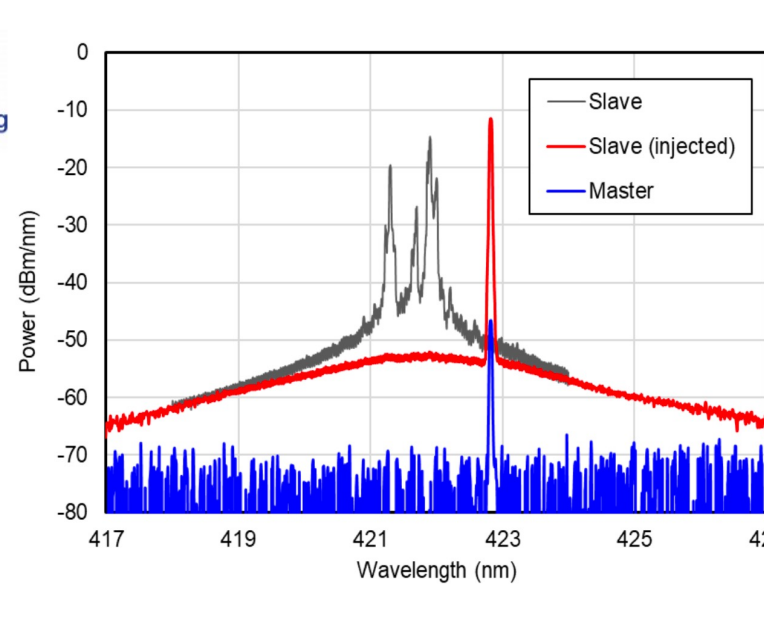
Sampling and dissolving it in HCl to get CaCl_2 (aq) and measure the isotope ratio by ICP-MS

$\text{Ca} + 2\text{H}_2\text{O} \rightarrow 2\text{Ca}(\text{OH})_2 + \text{H}_2$
Expose to air: $2\text{Ca} + \text{O}_2 \rightarrow 2\text{CaO}$
 $\text{CaO} + \text{CO}_2 \rightarrow 2\text{CaCO}_3$
React with DDW $\text{CaO} + \text{H}_2\text{O} \rightarrow \text{Ca}(\text{OH})_2$
Sampling for ICP-MS measurement:
 $\text{Ca}(\text{OH})_2 + 2\text{HCl} \rightarrow \text{CaCl}_2 + 2\text{H}_2\text{O}$
 $\text{CaCO}_3 + 2\text{HCl} \rightarrow \text{CaCl}_2 + \text{CO}_2 + \text{H}_2\text{O}$

Laser requirements

- Wavelength: ~ 422.792 nm
- Frequency stability: < 2 MHz rms
- Power scalability: > 100 W (1 unit)
- Long life time: $> 30,000$ hours
- Continuous wave (CW)
- High efficiency
- Low cost

Single frequency was obtained.



2 MHz rms → $422.792\text{xxxxx} \pm 0.0000006$ nm

< 2 MHz rms and long term operation was obtained

2W laser: 23 slave lasers

Power scalability of FP-LD laser system

Development of tapered semiconductor optical amplifier (SOA)

Collaborator: M. Uemukai (Osaka Univ.)

Tapered semiconductor optical amplifier

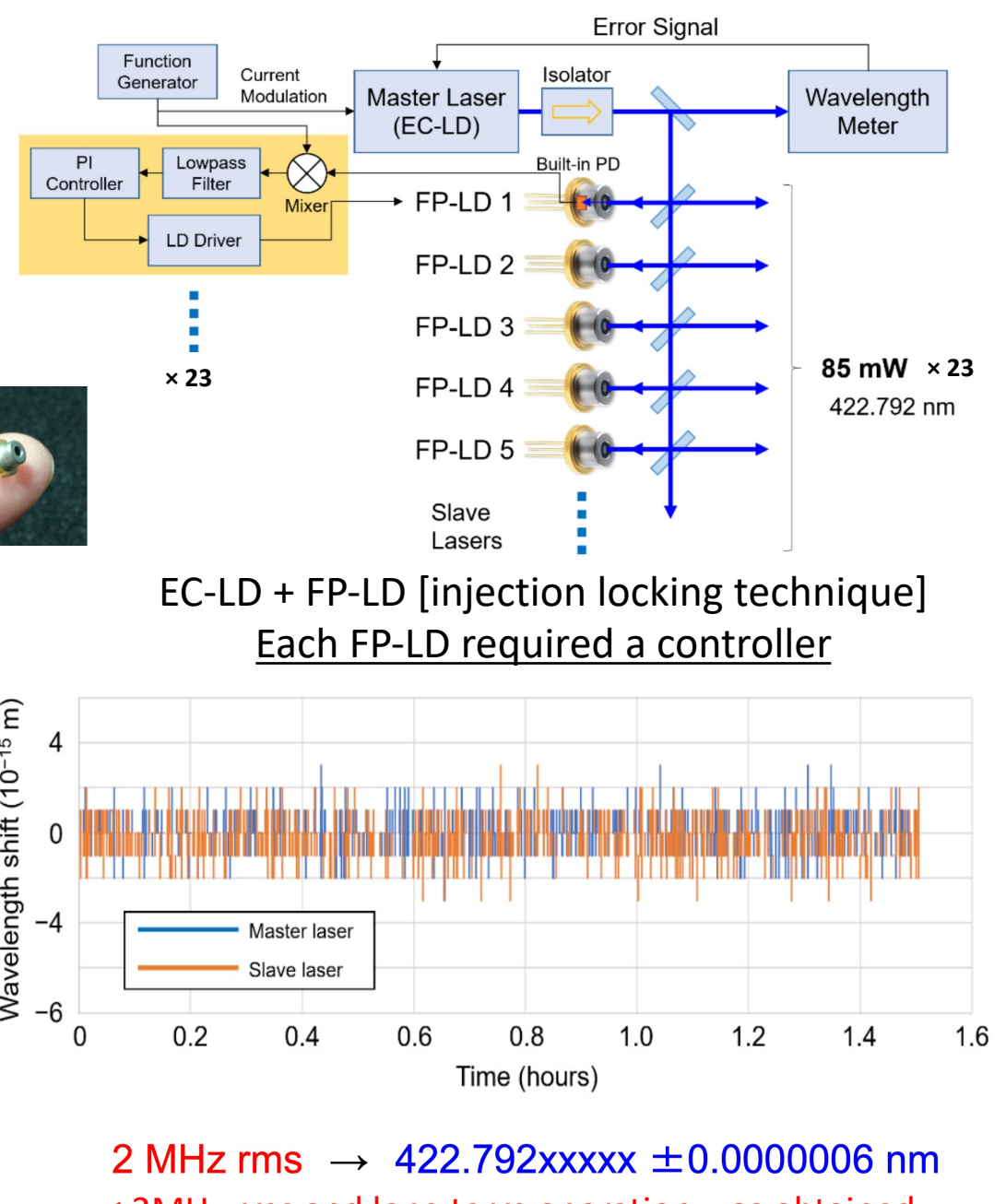
Tunable single-mode laser

InGaAs-based devices n-side electrode

Integrated single-frequency master laser and power amplifier system.

MOPA laser - Development of tapered semiconductor optical amplifier (SOA)

Professor Masahiro Uemukai, Osaka University



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Photon absorption and emission occur at definite timing.

High separation coefficient

Rabi oscillation (LISSE)

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